Form PTO-1449

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PF51568/MSI

Application Number 09/897,922

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7/5/01 1626 (Use several sheets if necessary) **U.S. PATENT DOCUMENTS** Exam. **Document** Sub-Fing Number Class Date Name Class 5,990,152 11/23/99 HETTCHE et al. 514 440 6,348,490 2/19/02 HETTCHE et al. 514 440 5,292,538 3/8/94 PAUL et al. 426 74 FOREIGN PATENT DOCUMENTS Document Sub-Fing Number Class Date Date Class Country ML 6518 12/9/68 **FRANCE** 702953 3/27/96 **EUROPE** 4419783 12/7/95 **GERMANY** 1668887 7/1/71 **GERMANY** 01/66560 9/13/01 PCT(WO) OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) Satent Abst. of Japan, Vol. 12, no. 22 (C-470), 1/22/88 (Abstract of JP 62) 175417A, 8/1/87). Monther DATE CONSIDERED

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KEIL & WEINKAUF

1350 Connecticut Avenue, N.W.

Washington, D.C. 20036